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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yoshiaki SHIMOOKA, et al.

SERIAL NUMBER: 10/052,259

GROUP: 2818

FILED: January 23, 2002

EXAMINER: LE, THAO P

FOR: SEMICONDUCTOR DEVICE USING A MULTILAYER WIRING STRUCTURE

REQUEST TO CORRECT TITLE OF INVENTION

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request correction of your records to reflect the correct title of the invention. The title of the invention should read as follows: SEMICONDUCTOR DEVICE **USING A MULTILAYER WIRING STRUCTURE.**

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


Marvin J. Spivak

Attorney of Record
Registration No. 24,913

Joseph A. Scafetta, Jr.
Registration No. 26, 803

Customer Number
22850

Tel.: (703) 413-3000
Fax: (703) 413-2220
(OSMMN 08/03)